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| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99) | Application Number | | 10596390 |
| | Filing Date | | 2006-06-12 |
| | First Named Inventor | YI, Seuyng-Hwan et al. | |
| | Art Unit | | |
| | Examiner Name | | |
| | Attorney Docket Number | P07596US00 | |

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| | 2 | 5009493 | | 1991-04-23 | Koch et al. | | |
| | 3 | 5116120 | | 1992-05-26 | Picker | | |
| | 4 | 5170064 | | 1992-12-08 | Howe | | |
| | 5 | 5341214 | | 1994-08-23 | Wong | | |
| | 6 | 5444249 | | 1995-08-22 | Wong | | |
| | 7 | 5488227 | | 1996-01-30 | Sweet | | |
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| 9 | 6067840 | | 2000-05-30 | Chelvayohan et al. | |
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| 2 | Noro, Makoto et al., "CO ₂ /H ₂ O Gas Sensor Using A Tunable Fabry-Perot Filter with Wide Wavelength Range" IEEE Conference on MEMS, pp. 319-322, 2003; 0-7803-7744-3 | <input type="checkbox"/> |
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- ☐ See attached certification statement.
- ☐ Fee set forth in 37 CFR 1.17 (p) has been submitted herewith.
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A signature of the applicant or representative is required in accordance with CFR 1.33, 10.18. Please see CFR 1.4(d) for the form of the signature.

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| Signature | /Bruce W. McKee/ | Date (YYYY-MM-DD) | 2006-08-24 |
| Name/Print | BRUCE W. MCKEE | Registration Number | 19651 |

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